



Docket No.: 52352-372

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|--|---|---------------------------|
| In re Application of | : | Customer Number: 20277 |
| Jeffrey A. SHIELDS, et al. | : | Confirmation Number: 8690 |
| Serial No.: 09/498,336 | : | Group Art Unit: 1765 |
| Filed: February 04, 2000 | : | Allowed: May 21, 2004 |
| | : | Examiner: V. Perez-Ramos |
| For: CF4 + H2O PLASMA ASHING FOR REDUCTION OF CONTACT/VIA RESISTANCE | : | |

LETTER SUBMITTING FORMAL DRAWINGS

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowability dated [date_allowed], submitted herewith are three (03) sheets of Formal Drawings in connection with the above referenced application.

Respectfully submitted,

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